

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Application No.: 10/798,653  
Applicants: Edmond BAILLOT, et al.  
Filed: March 11, 2004  
Title: Plasma cutting process with dual gas flow  
TC/A.U.: 3742  
Examiner: Mark H. Paschall  
Docket No.: Serie 6150  
Customer No.: 000040582

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of February 8, 2005, please amend the application as follows:

**Amendments to the Specification** begins on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begin on page 3 of this paper.

**Remarks** begin on page 7 of this paper.

An **Appendix** including an Abstract is attached following page 10 of this paper.

04/15/2005 YPOLITE1 00000035 011375 10798653

01 FC:1202 350.00 DA